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Bib Data Sheet

CONFIRMATION NO. 3106

SERIAL NUMBER 10/500,150	FILING DATE 07/12/2004 RULE	CLASS 438	GROUP ART UNIT 2818	ATTORNEY DOCKET NO. 255449US0PCT
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APPLICANTS

Takeshi Kumagai, Tokyo, JAPAN;

Hitoshi Katoh, Tokyo, JAPAN;

Jinsu Lee, Tokyo, JAPAN; Shingo Maku, Tokyo, JAPAN;

** CONTINUING DATA *****

This application is a 371 of PCT/JP03/00206 01/14/2003

** FOREIGN APPLICATIONS *****

JAPAN 2002005827 01/15/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature _____ Initials _____	STATE OR COUNTRY JAPAN	SHEETS DRAWING 6	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 3
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ADDRESS

22850

OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C.

1940 DUKE STREET

ALEXANDRIA, VA

22314

TITLE

Cvd method and device for forming silicon-containing insulation film

FILING FEE RECEIVED 920	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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